

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application of
 CHVIN T. GABRIEL, et al.
 Serial No.: 09/887,165

: Customer Number: 20277
 : Confirmation Number: 7774
 : Group Art Unit: 1763
 : Examiner: George A. Goudreau

Filed: June 25, 2001

For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST POISONING

Mail Stop No Fee - Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☒ Applicant is entitled to small entity status under 37 CFR 1.27
☒ Also attached: Petition For Reconsideration of Holding of Abandonment with copies of January 3, 2003 Page of Secretary Docket Book and January 3, 2003 Firm Master Docket

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	10	20	0	\$18.00 =	\$0.00
Independent Claims	2	3	0	\$86.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

[Signature]
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 Date: October 2, 2003